THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Mamoru NAKASUJI et al.

Group Art Unit: 2881

Application Number: 09/891,511

Examiner: Jack I. Berman

Filed: June 27, 2001

Confirmation Number: 8779

For: INSPECTION SYSTEM BY CHARGED PARTICLE BEAM AND METHOD OF

MANUFACTURING DEVICES USING THE SYSTEM

Attorney Docket Number:

010819

Customer Number:

38834

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

August 11, 2006

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated April 20, 2006 for one month from July 20, 2006 to August 20, 2006.

Attached please find a check in the amount of \$120.00 for the cost of the extension. If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

Michael J. Caridi

Attorney for Applicants Registration No. 56,171

Telephone: (202) 822-1100 Facsimile: (202) 822-1111

MJC/af

Enclosures:

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RCE Transmittal